

Docket No.: 543822003600

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Bjorn FISCHER et al.

Application No.: 10/777,207

Group Art Unit: 2818

Filed: February 13, 2004

Examiner: Not Yet Assigned

For: SEMICONDUCTOR DEVICE AND
CORRESPONDING FABRICATION METHOD

CLAIM FOR PRIORITY AND SUBMISSION OF DOCUMENT

Commissioner for Patents
2011 South Clark Place
Room 1B03, Crystal Plaza 2
Arlington, Virginia, 22202

Sir:


Applicants hereby claim priority under 35 U.S.C. 119 based on the following prior foreign application filed in the following foreign country on the date indicated:

<u>Country</u>	<u>Application No.</u>	<u>Date</u>
German	103 06 315.3	February 14, 2003

In support of this claim, a certified copy of the original foreign application is filed herewith.

Dated: July 9, 2004

Respectfully submitted,

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